



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

**Yosuke SHIRATA**

Group Art Unit: **2851**

Serial No.: **09/684,898**

Examiner: **NGUYEN, H.**

Filed: **October 10, 2000**

Confirmation No. **2212**

For: **LITHOGRAPHY SYSTEM AND METHOD**

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TECHNOLOGY CENTER 2800  
DEC 17 2002

Commissioner for Patents  
Washington, D.C. 20231

Date: December 16, 2002

Sir:

In response to the Office Action dated November 19, 2002, it is requested to reconsider the rejection.

#9  
10/20/02  
AG